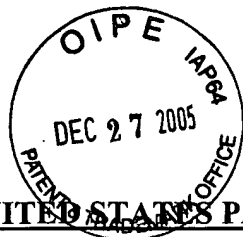


S/N 09/471,460



PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant:	Thomas A. Figura et al.	Examiner:	Calvin Lee
Serial No.:	09/471,460	Group Art Unit:	2818
Filed:	December 22, 1999	Docket No:	303.932US4
Title	USE OF A PLASMA SOURCE TO FORM A LAYER DURING THE FORMATION OF A SEMICONDUCTOR DEVICE		

**PETITION FOR A ONE-MONTH EXTENSION OF TIME**

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

In accordance with the provision of 37 CFR § 1.136(a), it is respectfully requested that a one-month extension of time be granted in which to respond to the Final Office Action mailed August 22, 2005, said period of response being extended from November 22, 2005 to December 22, 2005.

**Please charge Deposit Account No. 19-0743 in the amount of \$120.00 to cover the required extension fee. Please charge any additional fees or credit overpayment to deposit Account No. 19-0743.**

Respectfully Submitted

THOMAS A. FIGURA ET AL.

By their Representatives,

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.  
P.O. Box 2938  
Minneapolis, MN 55402  
(612) 349-9587

12/28/2005 CCHAU1 00000066 190743 09471460  
02 FC:1251 120.00 DA

Date:

22 Dec '05

By:

Timothy B. Clise

Reg. No: 40,957

**CERTIFICATE UNDER 37 CFR § 1.8:** The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 22 day of December 2005.

Name:

KATE GANNON

Signature: